

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

APPLICANT: Yasuhito Inagaki, et al.

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INVENTION: "SUBSTRATE CLEANING METHOD AND SUBSTRATE CLEANING
APPARATUS"

Assistant Commissioner of Patents
Washington, D.C. 20231

S I R:

Between the title and the heading "Background of the Invention" on page 1, insert the
following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Applications Nos. P2000-214974 filed
July 14, 2000, and P2000-240134 filed August 8, 2000, which applications are incorporated herein
by reference to the extent permitted by law.--

Respectfully submitted,



(Reg. No. 32,919)

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